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***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

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In re application of: Wu et al.

Attorney Docket No.:  
NOVLP091/NVLS-2889

Application No.: 10/820,525

Examiner: Maldonado, Julio J.

Filed: April 7, 2004

Group: 2823

Title: METHODS FOR PRODUCING LOW-K  
CDO FILMS WITH LOW RESIDUAL  
STRESS

Confirmation No: 8337

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CERTIFICATE OF EFS-WEB TRANSMISSION

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on November 9, 2009.

Signed: /Latonia Ervin/  
Latonia Ervin

**AMENDMENT F**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 7, 2009 in the above-identified application, please amend the application as follows:

**A Listing of the Claims** begins on page 2 of this paper.

**Remarks/Arguments** are on page 7 of this paper.